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Author Correction: Tailoring diamond's optical properties via direct femtosecond laser nanostructuring

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This Article contains an error in the Y axis of Figure 5, where 'LIPSS height (μm)' should read 'LIPSS height (nm)'. The correct Figure 5 appears below as Figure 1.

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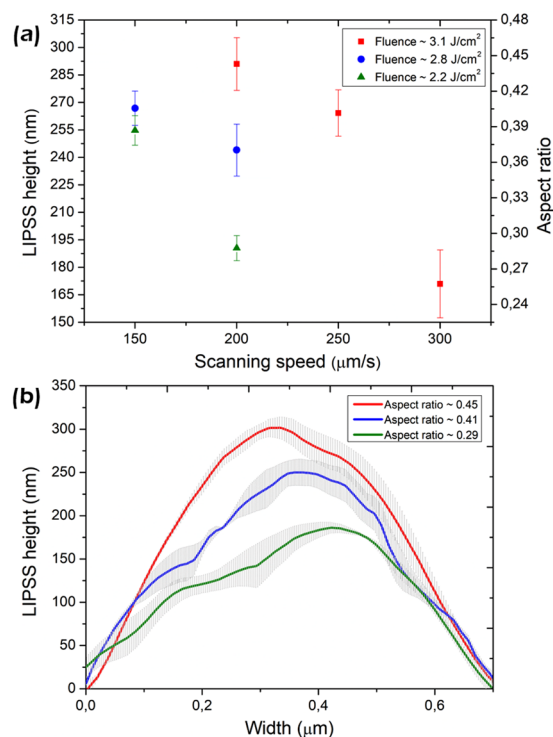


Figure 1. (a) AFM analysis of the LIPSSs height and aspect ratio A as function of fluence and scanning speed. (b) Average and standard deviation of structure profiles from fabricated nanopatterns with different A generated with: 3.12 J/cm^2 and $200 \mu\text{m/s}$ (high A), 2.8 J/cm^2 and $150 \mu\text{m/s}$ (intermediate A), 2.19 J/cm^2 and $200 \mu\text{m/s}$ (low A).



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